## **Polishing Slurry**

## Machplaner™

Machplaner<sup>™</sup> MS2000 Series are for sapphire polishing, MS3000 Series are for  $LiTaO_3/LiNbO_3$  polishing, ST2000 is for glass polishing. These slurries achieve high removal rate and good surface quality with optimization of particle design.

## **Machplaner™ Series**

## Physical Property

	MS2030	MS2105	MS3005 *1	ST2010
Particle Type	Colloidal Silica			
Silica wt%	42.0	52.0	52.0	22.5
рН	10.0-10.5	8.5-10.0	8.5-10.0	10.5-11.5
Particle Size(nm)	60-120	80-130	80-130	110-170
Specific Gravity	1.20-1.50	1.38-1.42	1.38-1.42	1.08-1.20
<b>Dilution Ratio</b>	2 times	3 times	2.5 times	Ready to use
Application	Sapphire c-plane	Sapphire c & a-plane	LiTaO₃ LiNbO₃	Glass
Advantages	Reduce a friction, Lower pad temperature	High RR Low cost	2 parts type (pH3.0-5.0) High RR	Surface roughness reduction

※1: This product is 2 components. The above data is shown as a physical property of A part.

- Machplaner<sup>™</sup> slurry achieves high removal rate and good surface quality with optimization of particle and additive design.
- Other applications such as Sapphire,
  Glass, Crystal, Oxide Materials and Resin are also covered by each polishing target.
- Free sample is available for first evaluation.



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<sup>\*\*</sup> The values such as a physical property indicated, show the standard value. The product specifications are not guaranteed.